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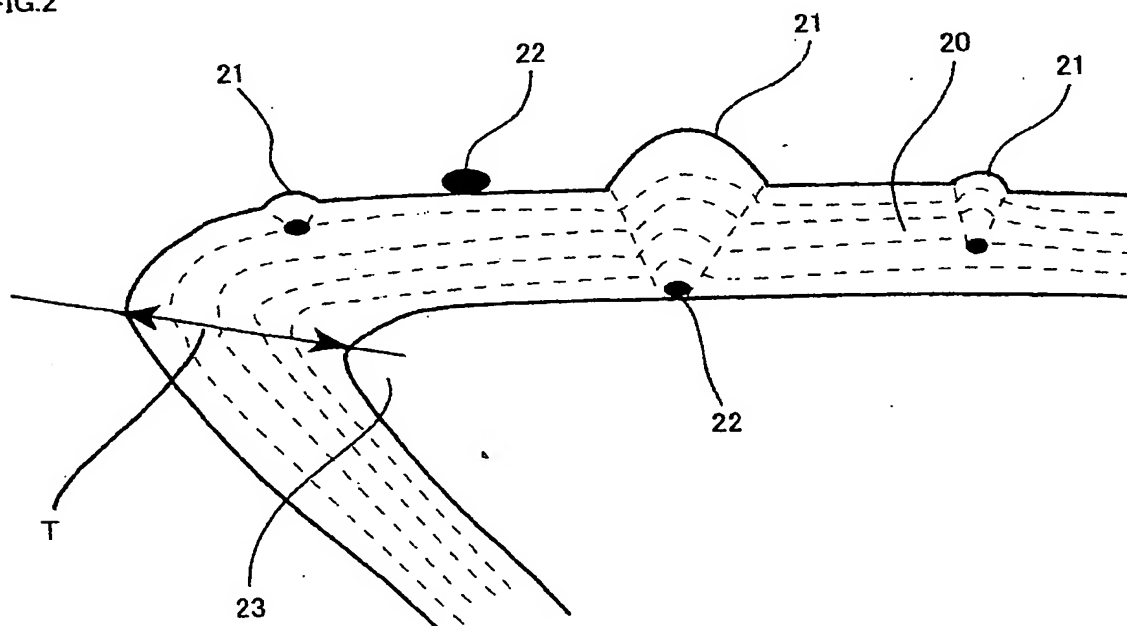
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(54) Apparatus and method for controlling the temperature of a substrate

(57) A substrate processing apparatus according to this invention includes a first chamber (1), a second chamber (3) which has a first valve (4) and a second valve (5), and communicates with the first chamber through said second valve, a thermoregulator which regulates a temperature of the substrate arranged in the

second chamber, and a controller (30) which controls a time for which the thermoregulator regulates the temperature of the substrate. A substrate transferred to the second chamber through the first valve is temporally held in the second chamber, and then transferred to the first chamber through the second valve.

FIG.2





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EUROPEAN SEARCH REPORT

Application Number
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The present search report has been drawn up for all claims			
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<p>CATEGORY OF CITED DOCUMENTS</p> <p>X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document</p> <p>T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons & : member of the same patent family, corresponding document</p>			

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